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10/052878

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10052878	11/02/2001	438	600 <sup>+</sup>	2814	PERALTA

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**\*\*CONTINUING DATA VERIFIED:**

THIS APPLICATION IS A CIP OF 08/500,728 07/11/1995 PAT 5,902,650  
WHICH IS A CON OF 09/249,041 02/12/1999 PAT 6,352,910

**\*\* FOREIGN APPLICATIONS VERIFIED:**

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

AMAT/827 - C 01

**TITLE :** Method of depositing amorphous silicon based films having controlled conductivity

U.S. DEPT. OF COMM./PAT & TM-PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for
			00
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drawg	Figs Drawg
			Print Fig
		Primary Examiner	
		Application Examiner	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	
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